Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
L11	437	(image near sensor) and (electro adj optical) and ("LCD" or liquid adj crystal adj device\$1)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/01/31 17:34
L12	248	11 and (active adj matrix)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/01/31 17:38
L13	248	12 not "Semiconductor Energy Laboratory Co., LTD"	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/01/31 17:38
L14	0	"Semiconductor Energy Laboratory Co., Ltd" not 12	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/01/31 17:38
S1	7	("2150017"):PN.	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2005/01/07 12:46
S2	. 0	("jp2150017").PN.	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2005/01/07 12:46
S3	0	("jp2150017").PN.	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2005/01/07 12:46
S4	0	("jp2150017").PN.	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2005/01/07 12:47

S5	13	(("5413958") or ("5529630") or ("5595923") or ("5767930") or ("5854494") or ("5966594") or ("5854096") or ("5712191") or ("5731613") or ("5937282") or ("5959313") or ("6051453") or ("6071764")).PN.`	USPAT	OR	OFF ·	2005/01/07 12:59
S6	18396	((438/128) or (438/149) or (438/151) or (438/154) or (438/164) or (438/174) or (438/180) or (438/181) or (438/194) or (438/197) or (438/199) or (438/217) or (438/29) or (438/275) or (438/276) or (438/278) or (438/287) or (438/289) or (438/290) or (438/291) or (438/290) or (438/301) or (438/311) or (438/364) or (438/365) or (438/369) or (438/378) or (438/479) or (438/491) or (438/514) or (438/517) or (438/778) or (438/791) or (438/795)).CCLS.	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2005/01/07 13:24
S7	4706	S6 and (p adj type same ((ion near2 implant\$5) or implant\$5 or dop\$3)) same ((semiconductor or silicon or polysilicon or polycrystalline or (single near2 crystal\$4) or (mono near2 crystal\$4)) same(region\$1 or layer\$1))	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/01/07 13:33
S8	364	S7 and (active near2 matrix)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/01/07 13:33
S9		S8 and ((lcd or (liquid adj crystal adj display)) and (image near2 sensor) and (electro adj optical adj device))	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR .	ON	2005/01/07 13:39
S10	. 3	("4727044"   "5147826"   "5313076") PN.	US-PGPUB; USPAT; USOCR	OR	OFF	2005/01/07 13:42
S11	301	S8 not S9	US-PGPUB; USPAT; USOCR	OR	OFF	2005/01/07 13:42

S12	4261	((conductive near (layer\$1 or film\$1)) or contact\$1 or electrod\$2) same (("Ti" or titanium) and ("Al" or aluminum)) same (interlayer\$1 or passivat\$4)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/01/31 14:22
S13	1132	S12 and (active near matrix)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/01/31:14:24
S14	93	S13 and (image near sensor) and (electro adj optical) and ("LCD" or liquid adj crystal adj device\$1)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/01/31 17:29
S15	93	S13 and ((image near sensor) and (electro adj optical) and ("LCD" or liquid adj crystal adj device\$1))	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/01/31 14:26
S16		S14 not S13	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/01/31 14:32
S17	1039	S13 not S14	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/01/31 14:33
S18	1039	S17 and (active near matrix)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/01/31 14:34
S19	2	("6081308":  "6380007").PN.	US-PGPUB; USPAT; USOCR	OR	OFF	2005/01/31 14:57